



AF JF
"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2815"

Docket No.: 243648US2S

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COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/678,061

Applicants: Keitaro IMAI et al.

Filing Date: October 6, 2003

For: SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME

Group Art Unit: 2815

Examiner: CHU, C. C.

SIR:

Attached hereto for filing are the following papers:

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

Our check in the amount of - is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2815"

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

KEITARO IMAI ET AL. : EXAMINER: CHU, C. C.

SERIAL NO: 10/678,061 :

FILED: OCTOBER 6, 2003 : GROUP ART UNIT: 2815

FOR: SEMICONDUCTOR DEVICE AND
METHOD OF MANUFACTURING
THE SAME :

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated July 27, 2005, Applicants respectfully request reconsideration of the above-identified application in view of the remarks as follows:

Remarks/Arguments begin on page 2 of this paper.